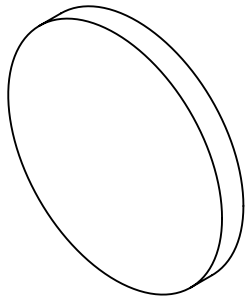
NOTES:

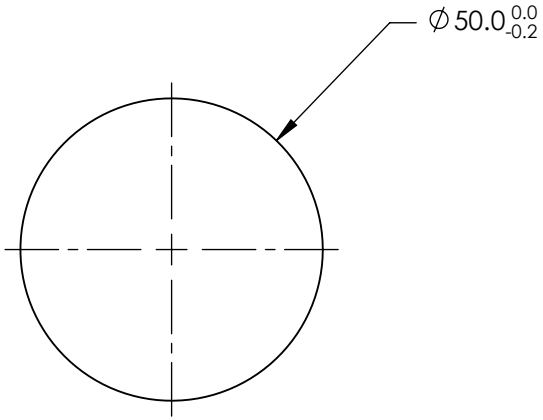
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 433 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 415nm @ 0° AOI
   T(abs): =50% FOR 425±4.25nm @ 0° AOI

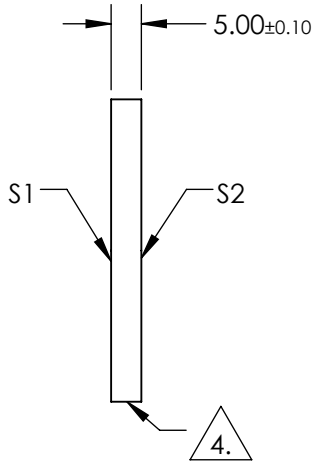
   S2:SINGLE LAYER MgF2

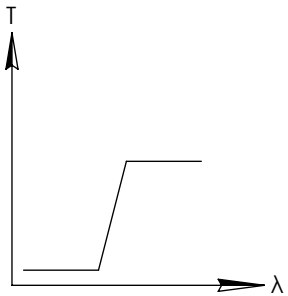
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 425nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84748	SHEET 1 OF 1

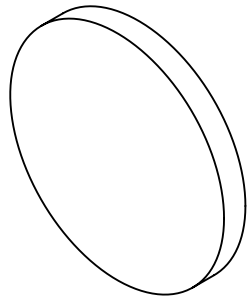
NOTES:

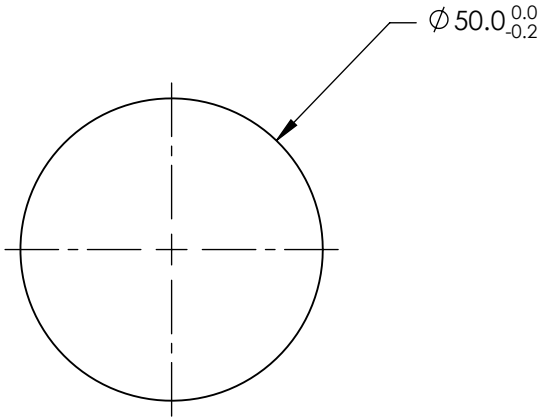
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 483 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 465nm @ 0° AOI
   T(abs): =50% FOR 475±4.75nm @ 0° AOI

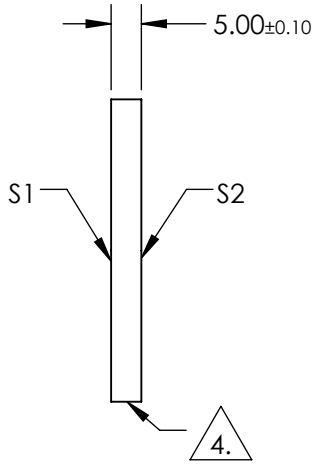
   S2:SINGLE LAYER MgF2

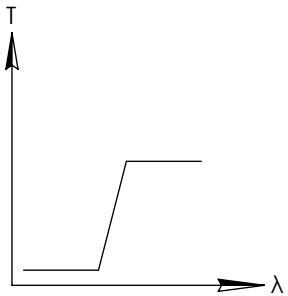
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 475nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84749	SHEET 1 OF 1

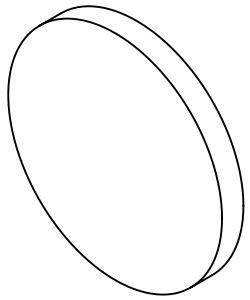
NOTES:

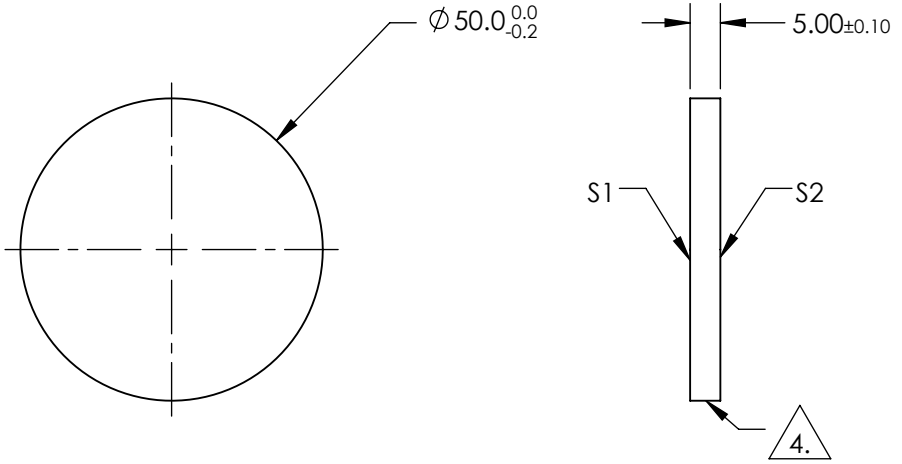
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 534 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 515nm @ 0° AOI
   T(abs): =50% FOR 525±5.25nm @ 0° AOI

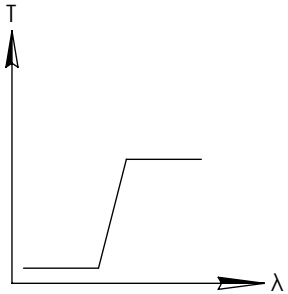
   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING







LONGPASS FILTER

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

Edmund Optics®

THIRD ANGLE PROJECTION

TITLE: Ø50mm, 525nm, HIGH PERFORMANCE LONGPASS FILTER

ALL DIMS IN: mm

DWG NO: 84750

SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 585 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 564nm @ 0° AOI
   T(abs): =50% FOR 575±5.75nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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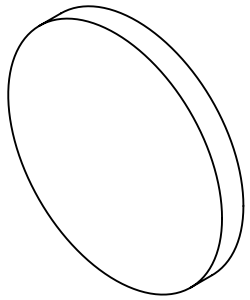
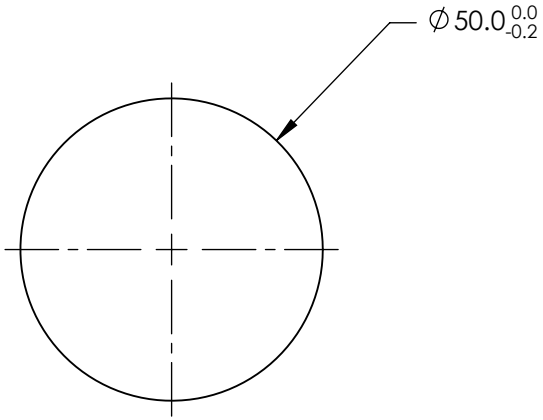
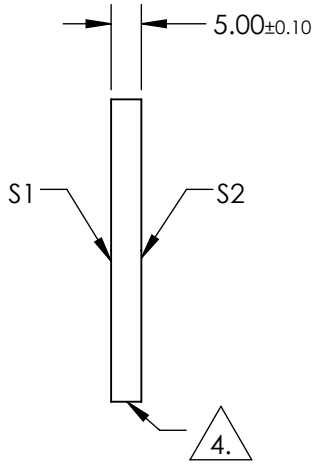
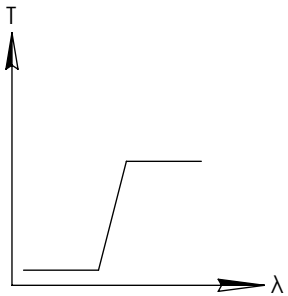








LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 575nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84751	SHEET 1 OF 1

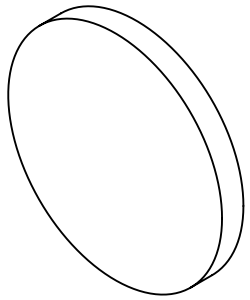
NOTES:

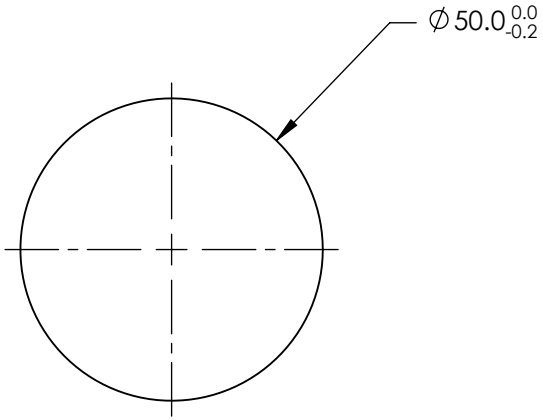
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 635 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 613nm @ 0° AOI
   T(abs): =50% FOR 625±6.25nm @ 0° AOI

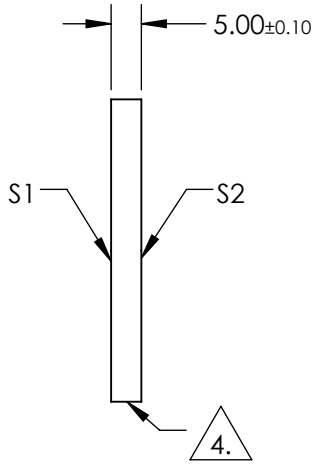
   S2:SINGLE LAYER MgF2

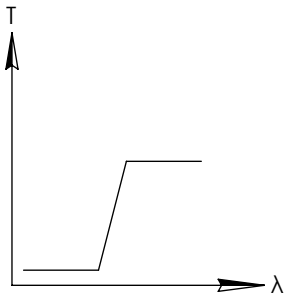
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 625nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84752	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 685 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 662nm @ 0° AOI
   T(abs): =50% FOR 675±6.75nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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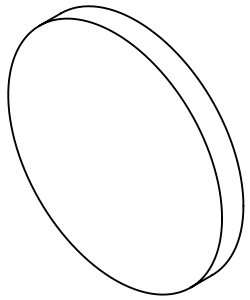
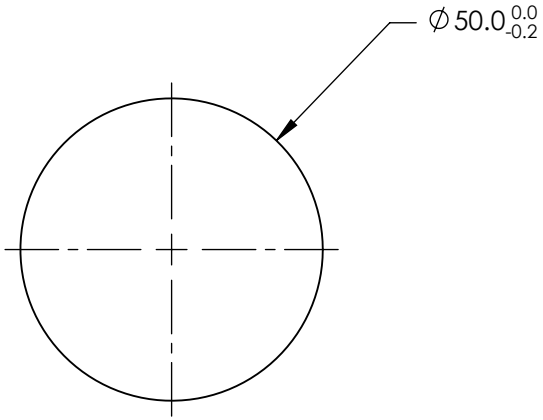
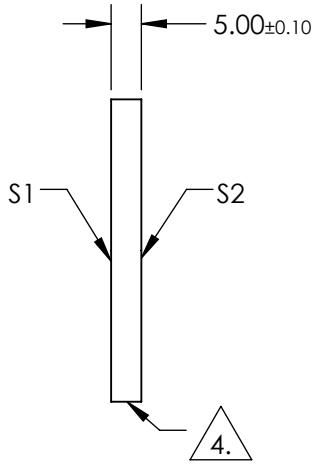
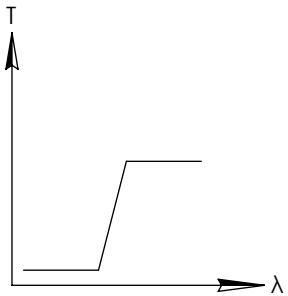








LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 675nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84753	SHEET 1 OF 1

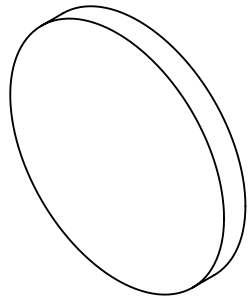
NOTES:

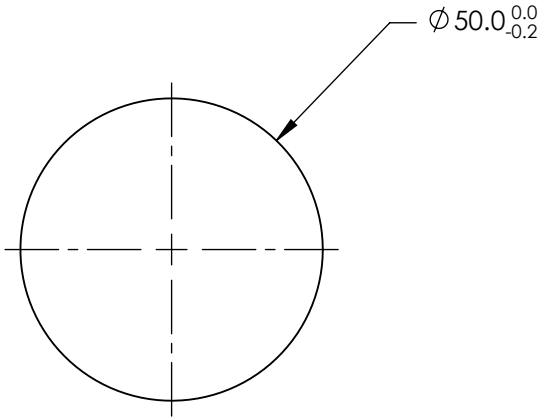
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 408 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 390nm @ 0° AOI
   T(abs): =50% FOR 400±4nm @ 0° AOI

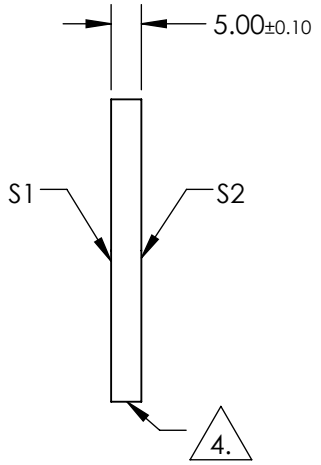
   S2:SINGLE LAYER MgF2

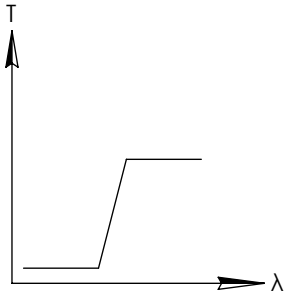
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 400nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84754	SHEET 1 OF 1

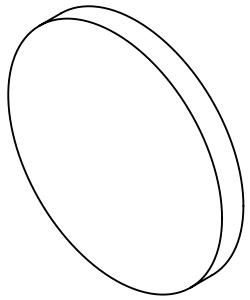
NOTES:

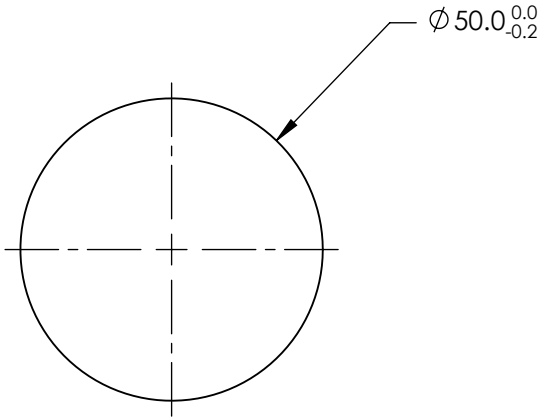
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 458 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 440nm @ 0° AOI
   T(abs): =50% FOR 450±4.5nm @ 0° AOI

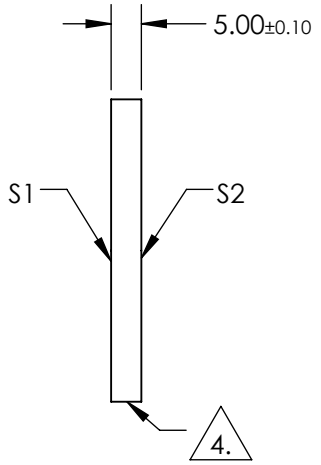
   S2:SINGLE LAYER MgF2

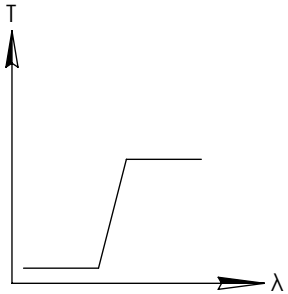
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 450nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84755	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 508 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 490nm @ 0° AOI
   T(abs): =50% FOR 500±5nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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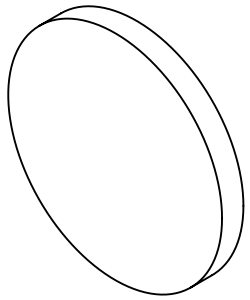
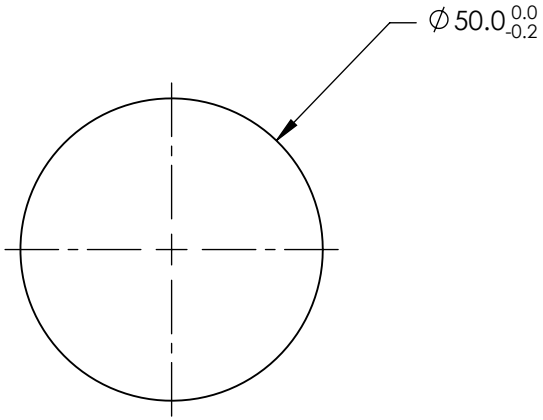
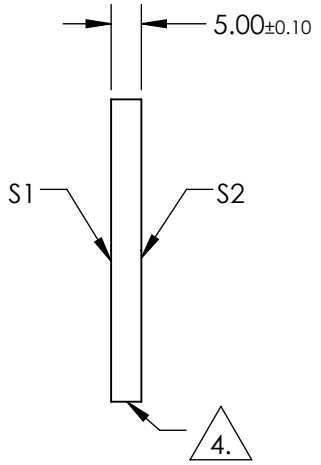
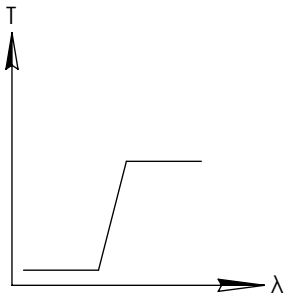








LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 500nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84756	SHEET 1 OF 1

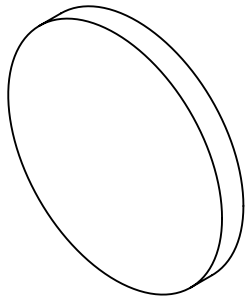
NOTES:

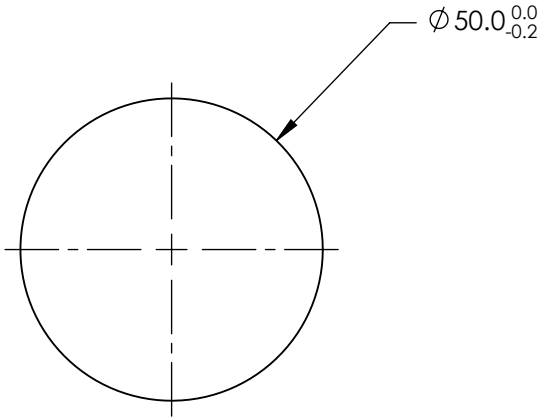
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 560 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 539nm @ 0° AOI
   T(abs): =50% FOR 550±5.5nm @ 0° AOI

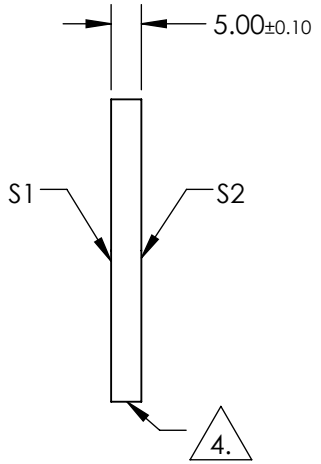
   S2:SINGLE LAYER MgF2

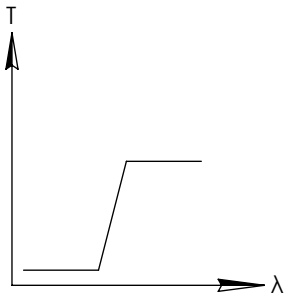
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 550nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84757	SHEET 1 OF 1

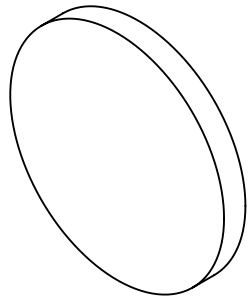
NOTES:

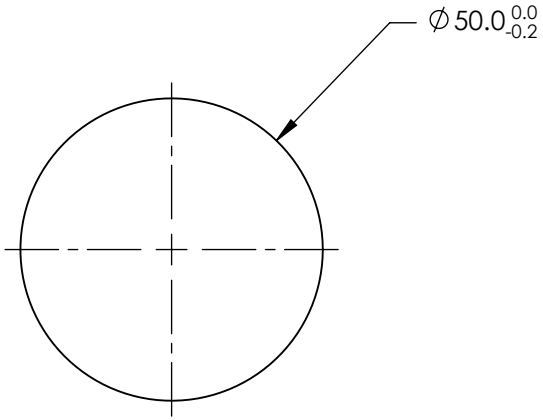
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 610 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 588nm @ 0° AOI
   T(abs): =50% FOR 600±6nm @ 0° AOI

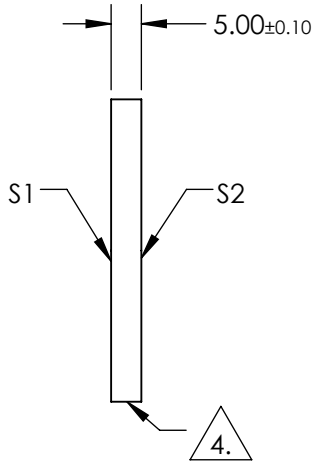
   S2:SINGLE LAYER MgF2

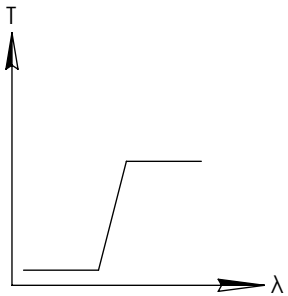
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 600nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84758	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 660 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 637nm @ 0° AOI
   T(abs): =50% FOR 650±6.5nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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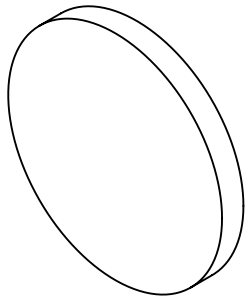

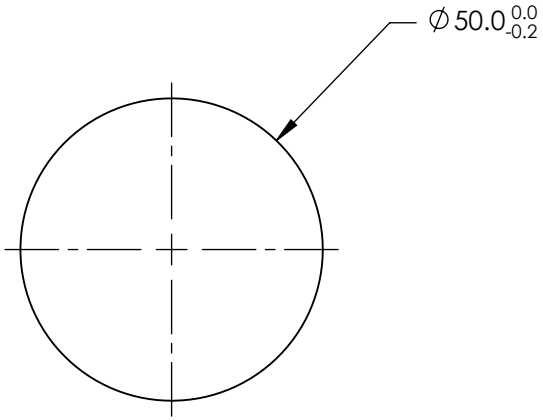

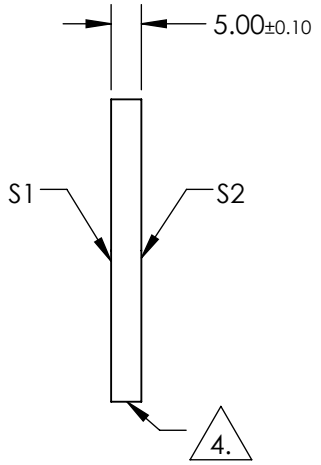

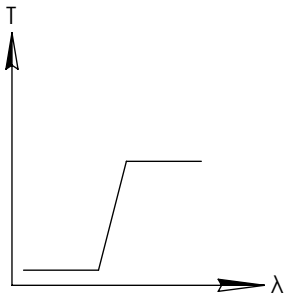

LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 650nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84759	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 710 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 686nm @ 0° AOI
   T(abs): =50% FOR 700±7nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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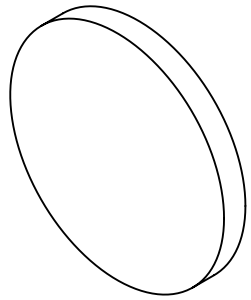
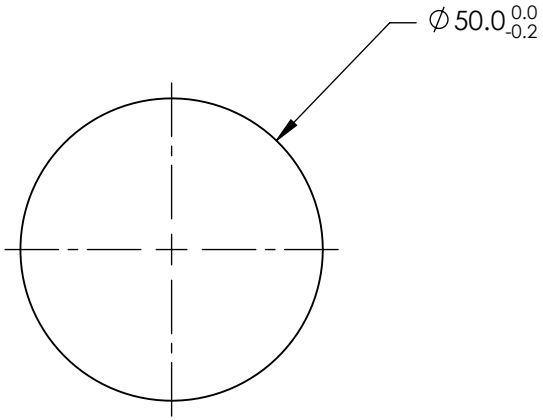
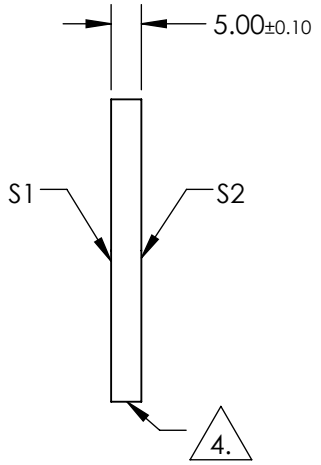
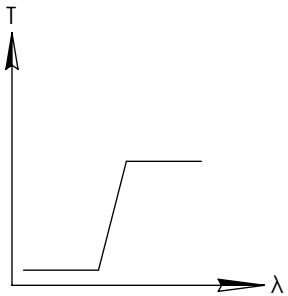








LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 700nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84760	SHEET 1 OF 1

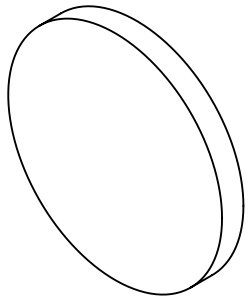
NOTES:

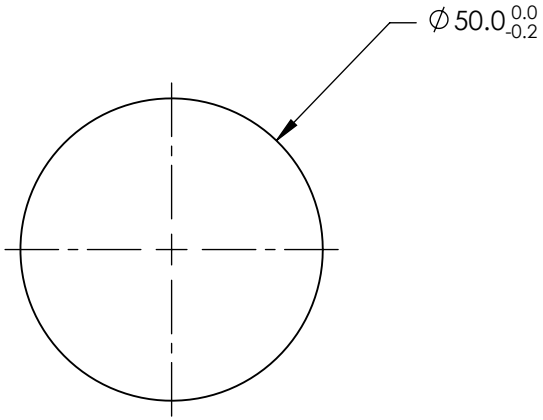
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 765 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 735nm @ 0° AOI
   T(abs): =50% FOR 750±7.5nm @ 0° AOI

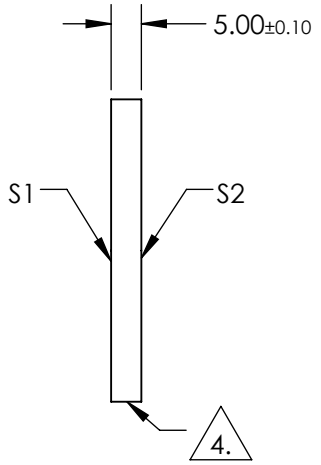
   S2:SINGLE LAYER MgF2

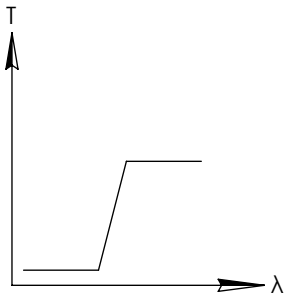
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 750nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84761	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 815 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 785nm @ 0° AOI
   T(abs): =50% FOR 800±8nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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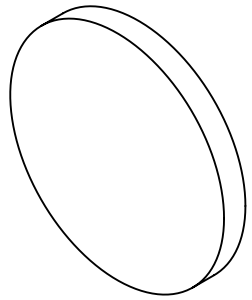
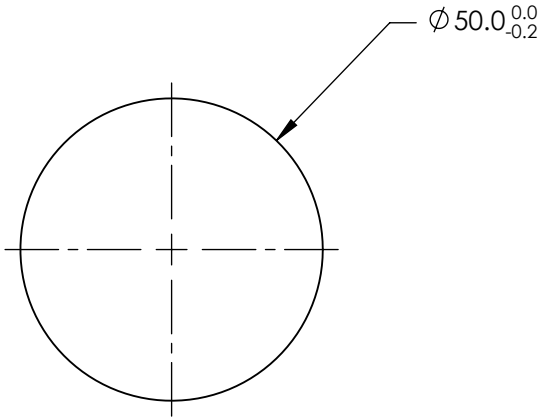
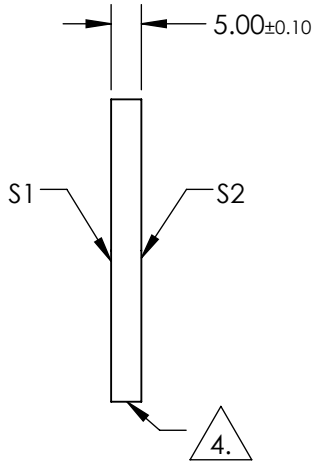
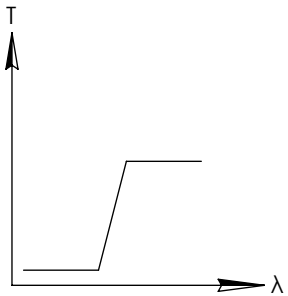








LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 800nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84762	SHEET 1 OF 1

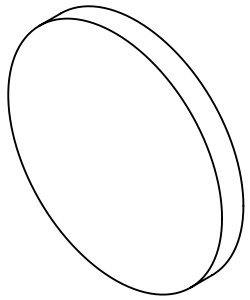
NOTES:

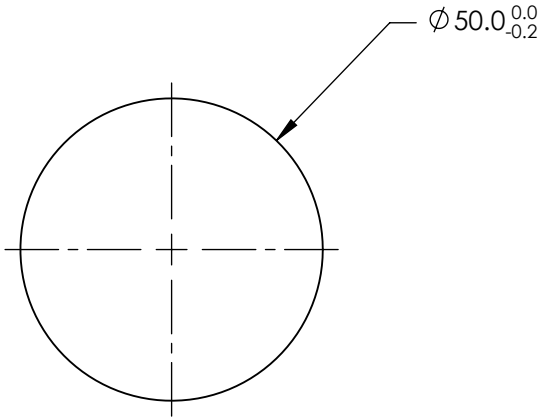
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 865 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 835nm @ 0° AOI
   T(abs): =50% FOR 850±8.5nm @ 0° AOI

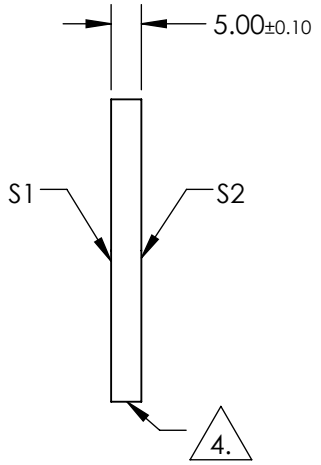
   S2:SINGLE LAYER MgF2

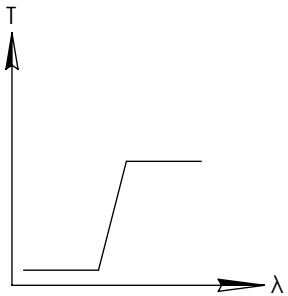
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 850nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84763	SHEET 1 OF 1

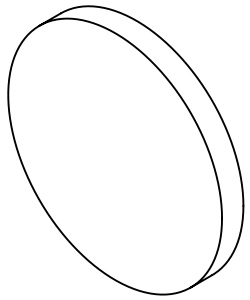
NOTES:

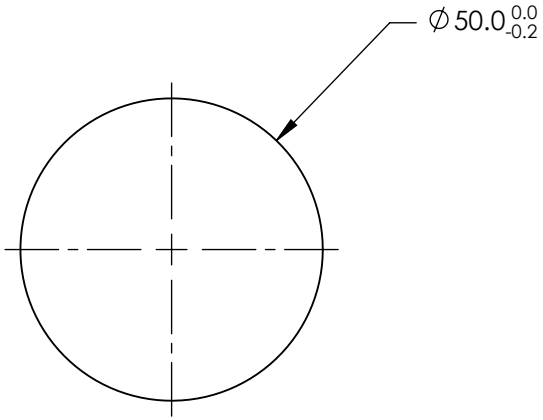
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 915 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 880nm @ 0° AOI
   T(abs): =50% FOR 900±9nm @ 0° AOI

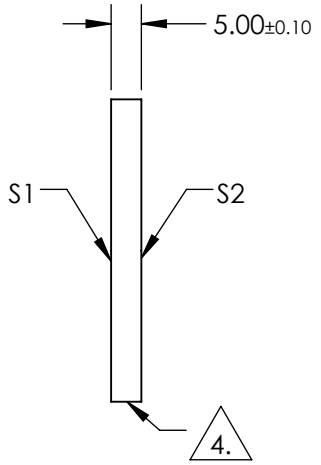
   S2:SINGLE LAYER MgF2

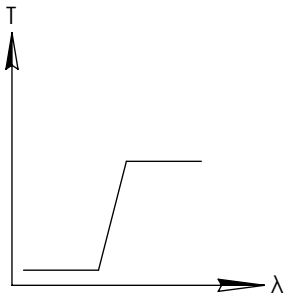
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 900nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84764	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 965 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 930nm @ 0° AOI
   T(abs): =50% FOR 950±9.5nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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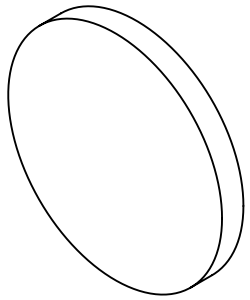
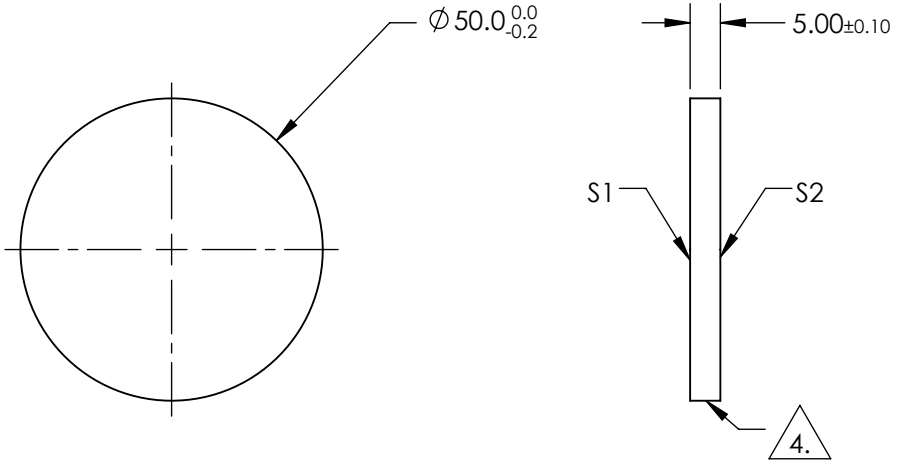
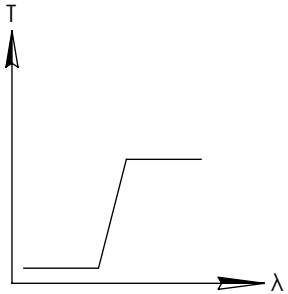






LONGPASS FILTER

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

Edmund Optics®

THIRD ANGLE PROJECTION

TITLE: Ø50mm, 950nm, HIGH PERFORMANCE LONGPASS FILTER

ALL DIMS IN: mm

DWG NO: 84765

SHEET 1 OF 1

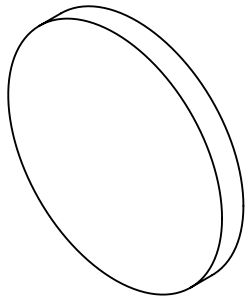
NOTES:

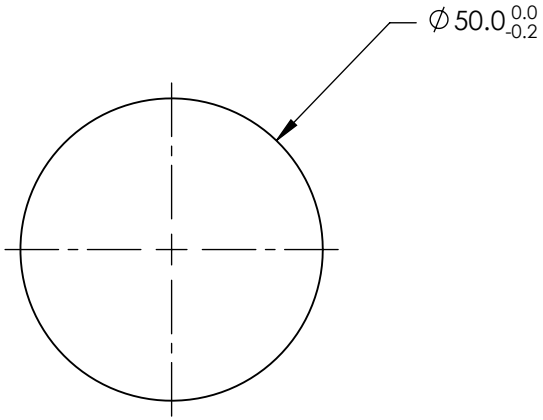
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 1020 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 980nm @ 0° AOI
   T(abs): =50% FOR 1000±10nm @ 0° AOI

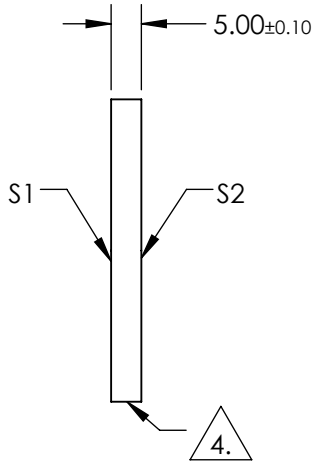
   S2:SINGLE LAYER MgF2

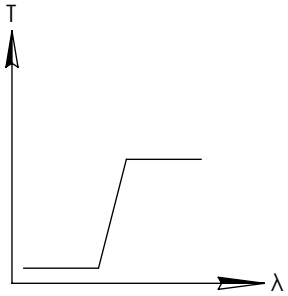
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 1000nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84766	SHEET 1 OF 1

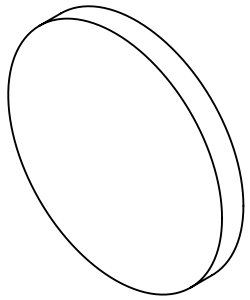
NOTES:

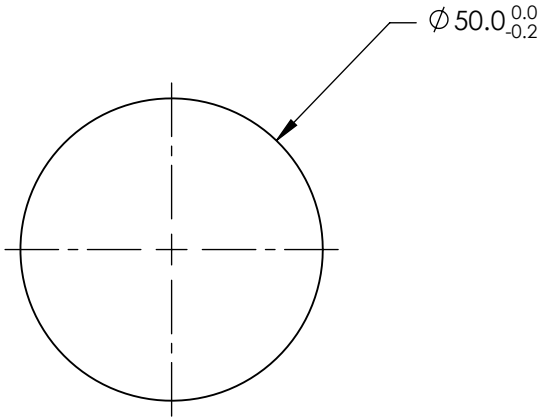
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 1070 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 1030nm @ 0° AOI
   T(abs): =50% FOR 1050±10.5nm @ 0° AOI

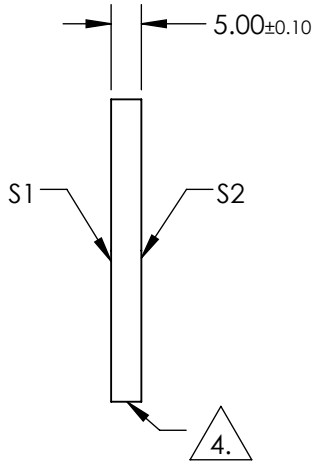
   S2:SINGLE LAYER MgF2

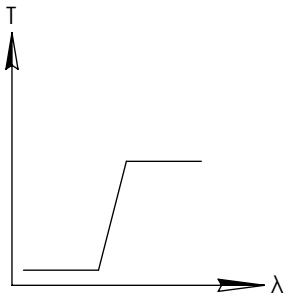
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 1050nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84767	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 1120 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 1080nm @ 0° AOI
   T(abs): =50% FOR 1100±11nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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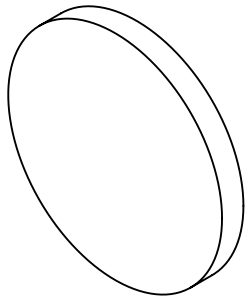

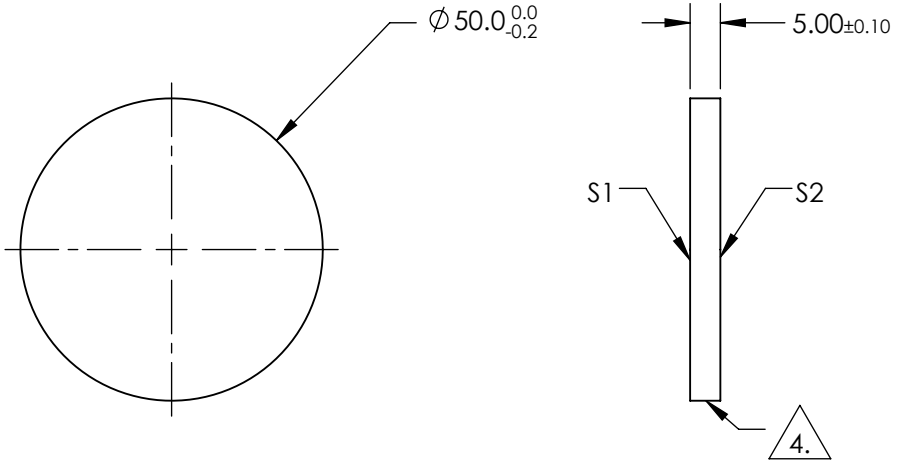

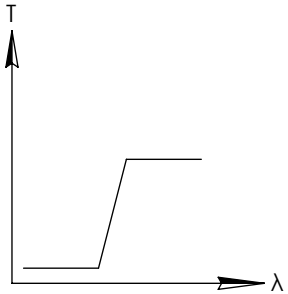

LONGPASS FILTER

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 1100nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84768	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 735 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 705nm @ 0° AOI
   T(abs): =50% FOR 725±7.25nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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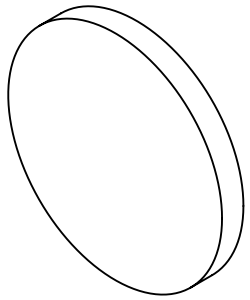
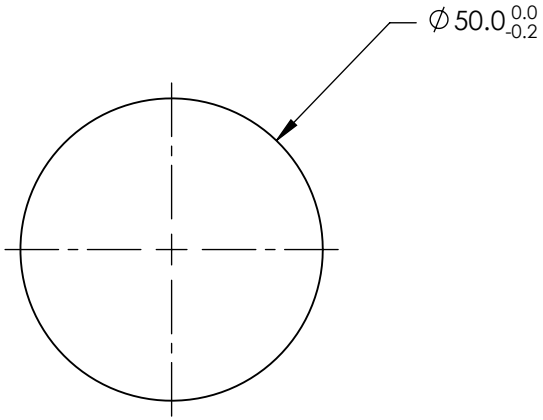
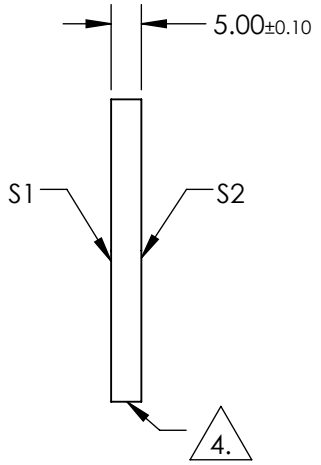
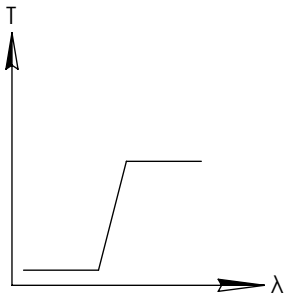








LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 725nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	86076	SHEET 1 OF 1

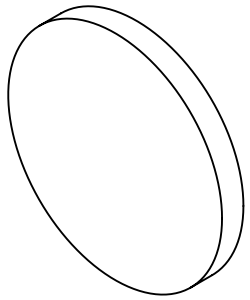
NOTES:

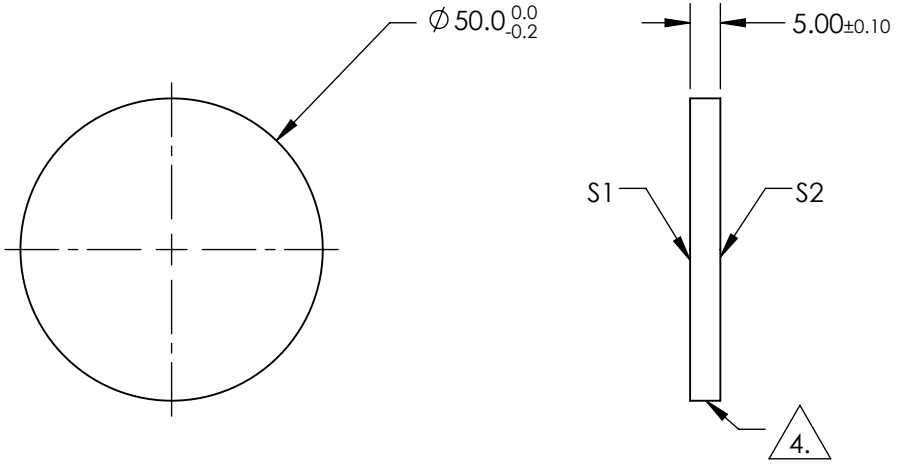
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 790 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 760nm @ 0° AOI
   T(abs): =50% FOR 775±7.75nm @ 0° AOI

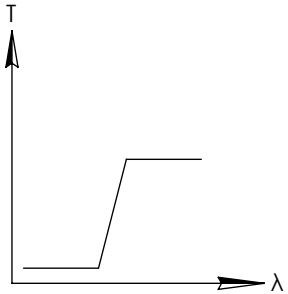
   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING







LONGPASS FILTER

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 775nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	86077	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 840 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 805nm @ 0° AOI
   T(abs): =50% FOR 825±8.25nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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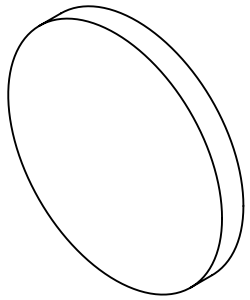
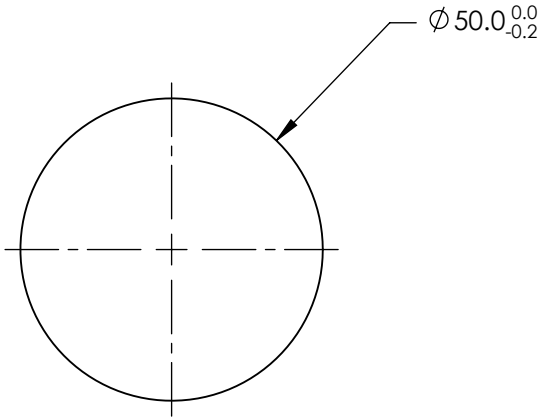
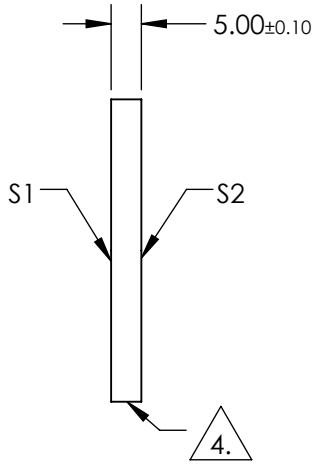
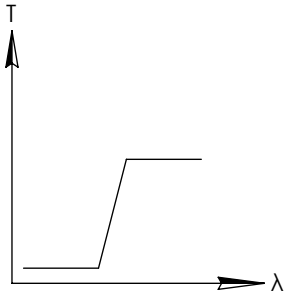








LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 825nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	86078	SHEET 1 OF 1

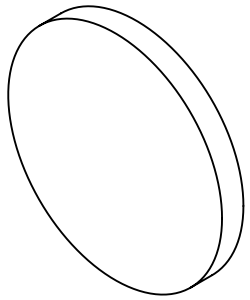
NOTES:

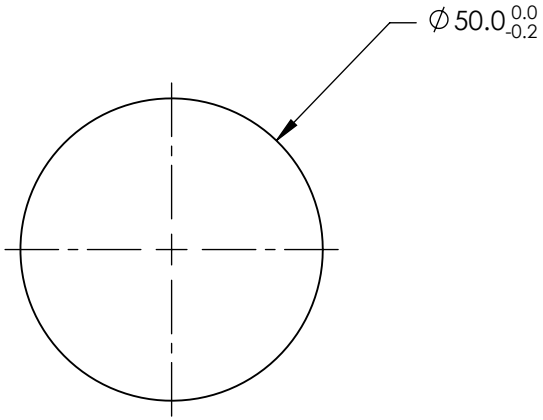
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 890 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 860nm @ 0° AOI
   T(abs): =50% FOR 875±8.75nm @ 0° AOI

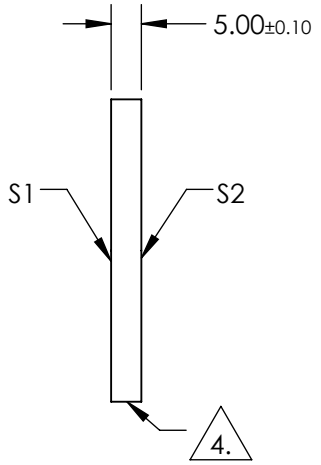
   S2:SINGLE LAYER MgF2

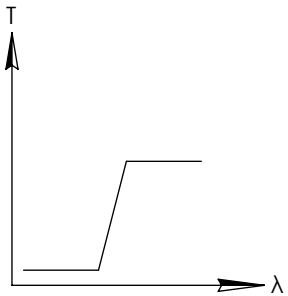
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 875nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	86079	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 940 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 905nm @ 0° AOI
   T(abs): =50% FOR 925±9.25nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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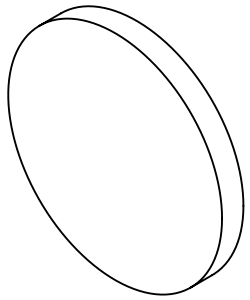
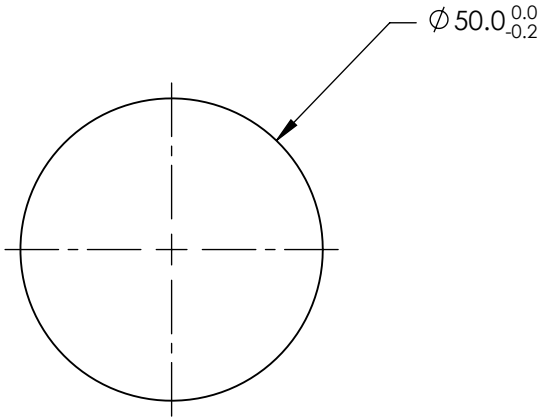
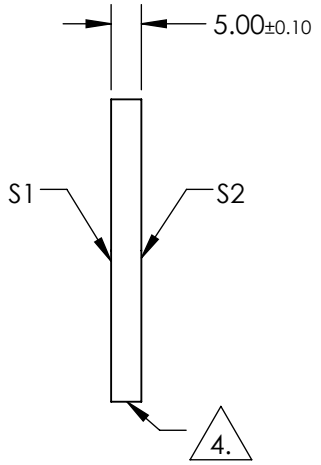
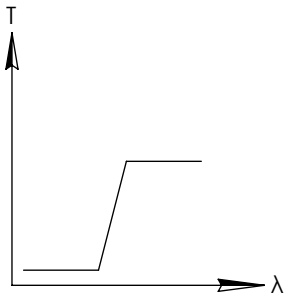








LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 925nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	86080	SHEET 1 OF 1

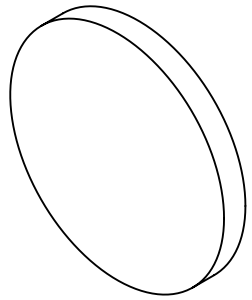
NOTES:

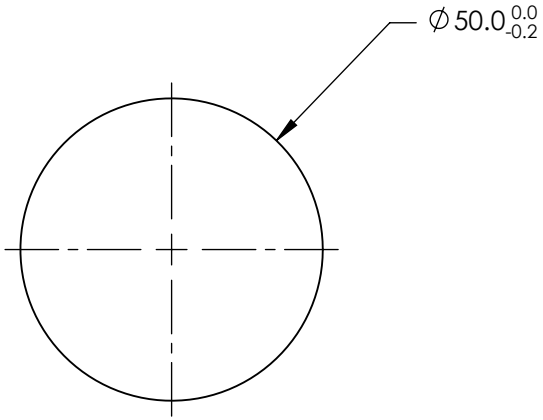
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 990 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 955nm @ 0° AOI
   T(abs): =50% FOR 975±9.75nm @ 0° AOI

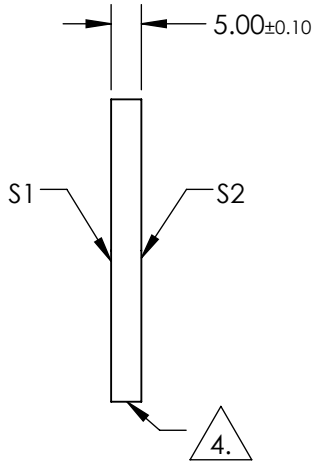
   S2:SINGLE LAYER MgF2

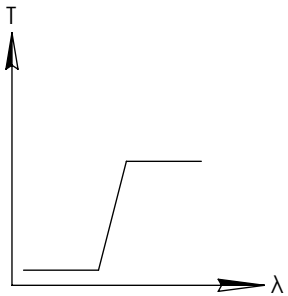
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 975nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	86081	SHEET 1 OF 1

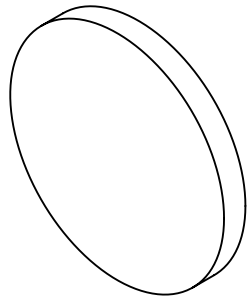
NOTES:

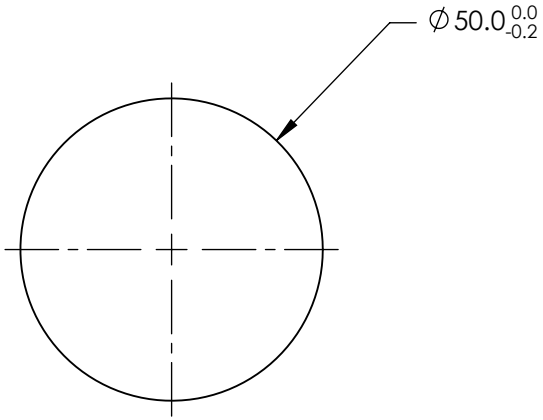
1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 1045 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 1005nm @ 0° AOI
   T(abs): =50% FOR 1025±10.25nm @ 0° AOI

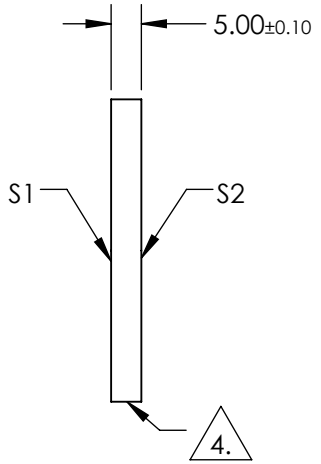
   S2:SINGLE LAYER MgF2

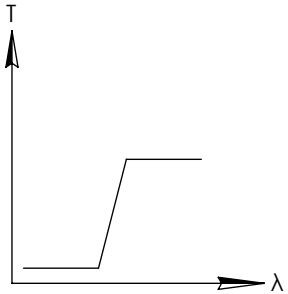
4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
DO NOT MANUFACTURE PARTS TO THIS DRAWING









LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 1025nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	86082	SHEET 1 OF 1

NOTES:

1. SUBSTRATE
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
   S1: HARD DIELECTRIC SPUTTERED
   T(avg): ≥91% FROM 1095 - 1650nm @ 0° AOI
   T(avg): ≤0.01% FROM 200 - 1055nm @ 0° AOI
   T(abs): =50% FOR 1075±10.75nm @ 0° AOI

   S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE
5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
7. ROHS COMPLIANT

FOR INFORMATION ONLY:
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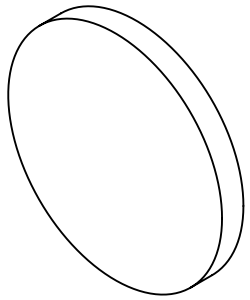

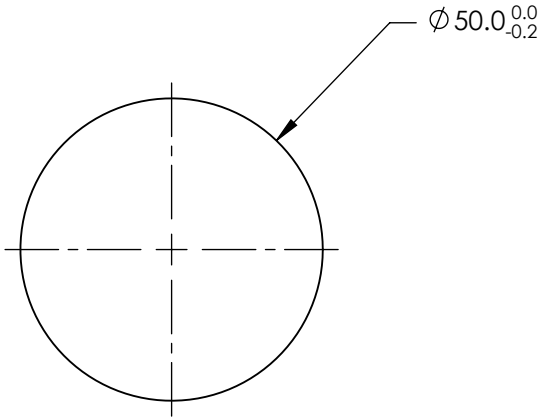

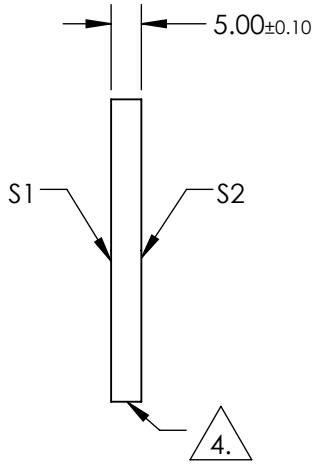

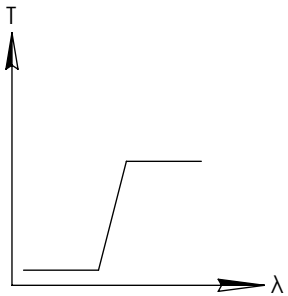

LONGPASS FILTER

REV A	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

Edmund Optics®

THIRD ANGLE PROJECTION		TITLE	Ø50mm, 1075nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	86083	SHEET 1 OF 1